



<u>PATENT</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Confirmation No.: 7023

In Haeng CHO

Group Art Unit: 1746

Serial No.: 10/685,793

Examiner: Joseph L. PERRIN

Filed: October 16, 2003

Customer No.: 34610

For:

WASHING MACHINE AND SYSTEM DATA CHANGING METHOD OF

THE SAME

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

U.S. Patent and Trademark Office 220 20th Street S. Customer Window - MAIL STOP IF Arlington, VA 22202

Sir:

The Examiner provided various reasons for allowance for the above-identified application in the Notice of Allowance dated September 22, 2004. Applicants respectfully note that the Examiner has misquoted the language recited in the claims.

Respectfully submitted,

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